

Sheet 1 of 1

FORM PTO-1449**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT(S)**

Atty Docket No.: 29273/521
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 Inventors : Masahiko SAITO, et al.
 Filed : 02 February 2000
 Group Art Unit : 2127
 Examiner : Kenneth Tang

U.S. PATENT DOCUMENTS

<u>Examiner Initial</u>	<u>Patent Number</u>	<u>Patent Date</u>	<u>Name</u>	<u>Class/ Subclass</u>	<u>Filing Date</u>
<u>KT</u>	5,826,081	10/20/98	ZOLNOWSKY	395/673	

FOREIGN PATENT DOCUMENTS

<u>Examiner Initial</u>	<u>Document Number</u>	<u>Date</u>	<u>Country</u>	<u>Class/ Subclass</u>	<u>Translation Yes</u>	<u>No</u>
<u>KF</u>	05-108380	04/30/93	Japan		ABS.	
<u>KF</u>	04-367037	12/18/92	Japan		ABS.	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

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1. The Survey of HITACHI Technology, HITACHI HYOURON, Japan, HITACHI HYOURON CORPORATION, Jan. 1999, Vol. 81, number 1, pages 27-29.

KF

2. Office Action (Rejection Reasons Notification) issued in the Japanese Priority Application No. heisei 11-041032, 27 April 2004 & translation thereof.

EXAMINER

Kenneth Tang

DATE CONSIDERED

10/12/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.